



	1	2	C	3	Document ID Δ	Title	Current OR
1	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	EP 1162605 A2	Method for forming operture, near field optical head and method for fabricoting the same and information recording/reading apparatus	
2	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	EP 1209690 A2	Method of fobricating optical aperture and method of fabricating probe for near field light device	
3	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	JP 2002071545 A	METHOD OF FORMING OPTICAL APERTURE	
4	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	JP 2002174581 A	PRODUCING METHOD FOR OPTICAL APERTURE	
5	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	JP 2002174583 A	PRODUCING METHOD FOR OPTICAL, APERTURE	
6	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	JP 2002174584 A	PRODUCING METHOD FOR OPTICAL APERTURE	
7	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	JP 2002174586 A	MANUFACTURING METHOD FOR OPTICAL APERTURE	
8	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	JP 2002181683 A	METHOD OF FORMING OPTICAL APERTURE AND NEAR-FIELD OPTICAL DEVICE FABRICATED THEREBY	
9	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	JP 2002181686 A	METHOD AND APPARATUS FOR MAKING OPTICAL APERTURE	
10	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20010011700 A1	METHOD OF FORMING A MICRO-APERTURE, PROJECTION HAVING A MICRO-APERTURE, PROBE OR MULTI-PROBE HAVING SUCH A PROJECTION AND SURFACE SCANNER, ALIGNER OR INFORMATION PROCESSOR COMPRISING SUCH A	250/234
11	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20010011704 A1	Near field optical probe and manufacturing method for same, and near-field optical apparotus using the near-field probe	250/310
12	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20010030938 A1	Recording medium, near field optical head, optical recording device, and method of manufacturing thereof	369/300
13	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20020001283 A1	Method for forming aperture, near field optical head and method for fabricoting the some and information recording/reoding opporotus	369/112.27
14	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20020047091 A1	Probe tip and method of manufacturing tips and probes for detecting microcurrent or microforce	250/234
15	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20020075569 A1	Method of fabricating optical operture and method of fobricating probe for near field light device	359/642
16	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20030075683 A1	Near field optical probe and monufactoring method thereof	250/306
17	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 4684206 A	Light waveguide with a submicron aperture, method for manufacturing the waveguide and applicotion of the woveguide in an optical memory	385/129
18	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 4725727 A	Waveguide for an optical near-field microscope	250/227.28
19	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 5838005 A	Use of focused ion and electron beams for fabricating a sensor on a probe tip used for scanning multiprobe microscopy and the like	250/306
20	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 5969345 A	Micromachined probes for nanometer scale measurements and methods of making such probes	250/234
21	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 6236783 B1	Optical fiber probe and manufacturing method therefor	385/43
22	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 6304527 B1	Near-field optical head and manufacturing method thereof and optical recording/readout system using near-field optical head	369/44.23
23	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 6408122 B1	Probe for irradiating with or detecting light and method for manufacturing the same	385/129
24	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 6441359 B1	Neor field optical sconning system employing microfabricated solid immersion lens	250/216